

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroshi SASAKI et al.

Application No.: 10/740,488

Filed: December 22, 2003

Docket No.: 118137

For: DIELECTRIC CERAMIC COMPOSITION, ELECTRONIC DEVICE AND THEIR  
PROCESS OF MANUFACTURINGINFORMATION DISCLOSURE STATEMENTCommissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of the non-English language references 1-4 is discussed in the present specification.
- ☒ 3. English-language Abstracts of the non-English language references 1-3 are attached hereto.
- ☒ 4. A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office (<http://www.jpo.go.jp>), and is attached, but has not been reviewed for accuracy. See References 1-3.

Respectfully submitted,

  
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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 118137		APPLICATION NO. 10/740,488	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANT(S) Hiroshi SASAKI et al.			
				FILING DATE December 22, 2003		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	1.	JP A 8-45348 w/abstract & transl.	2/16/1996	JAPAN			
	2.	JP A 11-278925 w/abstract & transl.	10/12/1999	JAPAN			
	3.	JP A 11-240753 w/abstract & transl.	9/7/1999	JAPAN			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	4.	Shigeki SHIBAGAKI et al.; " Phase and Microstructure of MgTiO <sub>3</sub> Ceramic Fired in Reducing Atmosphere"; pp 1261-1265					
EXAMINER				DATE CONSIDERED			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: February 9, 2004